

Application No.	Applicant(s)	
10/615,616	PULLEN ET AL.	
Examiner	Art Unit	
James K. Trujillo	2116	

SEARCHED				
Class	Subclass	Date	Examiner	
323	282,283 284,285 224 300	11/10/04	44	
713	300	+		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
323	282, 283 284, 285	11/1404	fet	
321	224	11/17/04	V	
713	300	7		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
BATABASES SEARCHED: EAST NPL: IEEE ACM SEE ATTACHED	11/16/04	£KT		
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